

Application/Control No.	Applicant(s)/Patent under Reexamination
10/600,141	RHODES ET AL.
Examiner	Art Unit
Jim Vannucci	2828

	SEAR	CHED	
Class	Subclass	Date	Examiner
372	5	10/12/2005	٦V
372	91	10/12/2005	JV
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INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
same a	s above	10/12/2005	J۷

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
non-linear mode, plasma, laser, x-ray	10/12/2005	٦V		
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